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INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANTS Hubert GRANGE et al.			
				FILING DATE December 30, 2005			

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
/AWO/	1	5,750,420	05/12/1998	Bono et al.		
/AWO/	2	6,004,832	12/21/1999	Haller et al.		
/AWO/	3	5,824,608	10/20/1998	Gotoh et al.		
/AWO/	4	5,489,556	02/06/1996	Li et al.		

FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
/AWO/	5	EP 0 456 029 A1	11/13/1991	Europe		

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)		
/AWO/	6	Alley et al., "The Effect of Release-Etch Processing on Surface Microstructure Stiction," Solid-State Sensor and Actuator Workshop, 5 th Technical Digest, IEEE Hilton , pp. 202-207, 1992

EXAMINER /Allan Olsen/	DATE CONSIDERED 03/31/2007
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Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Date: December 30, 2005